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APPLICATION NO.	FILING DATE		IED INVENTOR	07977/242001
09/050,182	03/26/ 9 8	OHNUMA		

IM22/0716

SCOTT C HARRIS FISH & RICHARDSON 4225 EXECUTIVE SQUARE SUITE 1400 LA JOLLA CA 92037

EXAMINER

KUNEMUND, R

PAPER NUMBER ART UNIT 1765

07/16/99 DATE MAILED:

Please find below and/or attached an Office communication concerning this application or proceeding.

Commissioner of Patents and Trademarks

•		Applicant(s)	l
• •	Application No. 09/050,182		Ohnuma et al	
Office Action Summary	Examiner Robert Kuner		1765	
Responsive to communication(s) filed on				· · · · · · · · · · · · · · · · · · ·
Responsive to communication		prosec	ution as to the merit	is is closed
This action is FINAL . Since this application is in condition for allowance in accordance with the practice under <i>Ex parte</i> of shortened statutory period for response to this action to become abandoned. (35 U.S.C. § 13 CFR 1.136(a).	e except for formal matte Quayle, 1935 C.D. 11; 45 ction is set to expire ion. Failure to respond w 33). Extensions of time m	ithin the policy be obtained	eriod for response was ained under the prov	visions of
		is	a/are pending in the	application.
		is/a	are withdrawn from	Consideration
			is/are allowed.	
			is/are rejected.	
			is/are objected	to.
☐ Claim(s) 1-32☐ Claim(s)☐ Claims	are s	ubiect to r	restriction or election	n requirement.
Claim(s)	dio c	,		
Application Papers See the attached Notice of Draftsperson's The drawing(s) filed on The proposed drawing correction, filed or The specification is objected to by the Ex The oath or declaration is objected to by Priority under 35 U.S.C. § 119 Acknowledgement is made of a claim for All	the Examiner. or foreign priority under 3: ERTIFIED copies of the pri es Code/Serial Number)	S U.S.C. §	119(a)-(d). ments have been eau (PCT Rule 17.2)	
Attachment(s) ☒ Notice of References Cited, PTO-892 ☐ Information Disclosure Statement(s), ☐ Interview Summary, PTO-413 ☒ Notice of Draftsperson's Patent Drav ☐ Notice of Informal Patent Application	PTO-1449, Paper No(s). ving Review, PTO-948			

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The Rejections

The nonstatutory double patenting rejection is based on a judicially created doctrine grounded in public policy (a policy reflected in the statute) so as to prevent the unjustified or improper timewise extension of the "right to exclude" granted by a patent and to prevent possible harassment by multiple assignees. See In re Goodman, 11 F.3d 1046, 29 USPQ2d 2010 (Fed. Cir. 1993); In re Longi, 759 F.2d 887, 225 USPQ 645 (Fed. Cir. 1985); In re Van Ornum, 686 F.2d 937, 214 USPQ 761 (CCPA 1982); In re Vogel, 422 F.2d 438, 164 USPQ 619 (CCPA 1970); and, In re Thorington, 418 F.2d 528, 163 USPQ 644 (CCPA 1969).

A timely filed terminal disclaimer in compliance with 37 CFR 1.321© may be used to overcome an actual or provisional rejection based on a nonstatutory double patenting ground provided the conflicting application or patent is shown to be commonly owned with this

Effective January 1, 1994, a registered attorney or agent of record may sign a terminal application. See 37 CFR 1.130(b). disclaimer. A terminal disclaimer signed by the assignee must fully comply with 37 CFR 3.73(b).

Claims 1 to 32 are rejected under the judicially created doctrine of obviousness-type double patenting as being unpatentable over claims 1-31 of U.S. Patent No. 5,700,333. Although the conflicting claims are not identical, they are not patentably distinct from each other because the difference is the device formed and heating. However, in the absence of unobvious results, it would have been obvious to one of ordinary skill in the art to determine through routine experimentation the optimum, operable device formed as the instant claims form any device and heating in order to decrease heating time.

The following is a quotation of 35 U.S.C. 103(a) which forms the basis for all obviousness rejections set forth in this Office action:

⁽a) A patent may not be obtained though the invention is not identically disclosed or described as set forth in section 102 of this title, if the differences between the subject matter sought to be patented and the prior art are such that the subject matter as a whole would have been obvious at the time the invention was made to a person having ordinary skill in the art to which said subject matter pertains. Patentability shall not be negatived by the manner in which the invention was made.

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This application currently names joint inventors. In considering patentability of the claims under 35 U.S.C. 103(a), the examiner presumes that the subject matter of the various claims was commonly owned at the time any inventions covered therein were made absent any evidence to the contrary. Applicant is advised of the obligation under 37 CFR 1.56 to point out the inventor and invention dates of each claim that was not commonly owned at the time a later invention was made in order for the examiner to consider the applicability of 35 U.S.C. 103© and potential 35 U.S.C. 102(f) or (g) prior art under 35 U.S.C. 103(a).

Claims 1 to 16 are rejected under 35 U.S.C. 103(a) as being unpatentable over Yamazaki et al (5,700,333)...

The Yamazaki et al reference teaches a method of device formation. On a substrate, a layer of amorphous silicon is deposited and then catalysts are placed in contact with the silicon. The silicon is heated in order to crystallize the silicon. Then a gettering agent is added to the silicon layer. Then the structure is reheated to remove the catalyst. The second heating step is around 550°c, note entire reference. The sole difference between the instant claims and the prior art is the device formed. However, in the absence of unobvious results, it would have been obvious to one of ordinary skill in the art to determine through routine experimentation the optimum, operable types of devices made in the Yamazaki et al reference in order to create devices with low impurity silicon layer.

Claims 17 to 32 are rejected under 35 U.S.C. 103(a) as being unpatentable over Yamazaki et al (5,700,333) in view of Zhang et al (5,569,936)

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The Yamazaki et al reference is relied on for the same reasons as stated, supra, and differs from the instant claims in the use of lasers to crystallize the silicon. However, the Zhang et al reference teaches catalyst crystallization of amorphous silicon by using lasers, note figures. It would have been obvious to one of ordinary skill in the art to modify the Yamazaki et al reference by the teachings of the Zhang et al reference to use lasers in order to decrease the time of crystallization.

Examiner's Remarks

The remaining references are merely cited of interest as showing the state of the art.

Any inquiry concerning this communication or earlier communications from the examiner should be directed to Robert Kunemund whose telephone number is (703) 308-1091. The examiner can normally be reached on Monday through Friday from 7:00 to 3:30.

If attempts to reach the examiner by telephone are unsuccessful, the examiner's supervisor, Ben Utech, can be reached on (703) 308-3836. The fax phone number for this Group is (703) 305-6357.

Any inquiry of a general nature or relating to the status of this application or proceeding should be directed to the Group receptionist whose telephone number is (703) 308-0661.

RMK

July 14, 1999

ROBERT KUNEMUND PRIMARY PATENT EXAMINER A.U. @1765